	Application No.	Applicant(s)	
Notice of Allowability	10/707,560 Examiner	WU, YI-JEN Art Unit	
	Examiner	Artonit	
	Tarifur R. Chowdhury	2871	
The MAILING DATE of this communication app All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85 NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT R of the Office or upon petition by the applicant. See 37 CFR 1.31	S (OR REMAINS) CLOSED in to or other appropriate commune RIGHTS. This application is su	his application. If not included ication will be mailed in due course. THI S	
1. \boxtimes This communication is responsive to <u>amendment filed on</u>	<u>01/26/06</u> .		
2. The allowed claim(s) is/are 10-16,18 and 19.			
3. Acknowledgment is made of a claim for foreign priority u a) All b) Some* c) None of the:		(f) .	
1. Certified copies of the priority documents hav			
2. Certified copies of the priority documents hav	• • • • • • • • • • • • • • • • • • • •		
3. Copies of the certified copies of the priority do	ocuments have been received	n this national stage application from the	9
International Bureau (PCT Rule 17.2(a)).			
* Certified copies not received:			
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDON! THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		reply complying with the requirements	
4. A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which give			
5. CORRECTED DRAWINGS (as "replacement sheets") mu	ist be submitted.		
(a) \square including changes required by the Notice of Draftsper	son's Patent Drawing Review	(PTO-948) attached	
1) hereto or 2) to Paper No./Mail Date	<u>.</u>		
(b) ☐ including changes required by the attached Examiner Paper No./Mail Date	's Amendment / Comment or in	n the Office action of	
Identifying indicia such as the application number (see 37 CFR each sheet. Replacement sheet(s) should be labeled as such in			
6. DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT			
Attachment(s) 1. ☐ Notice of References Cited (PTO-892)	5. ☐ Notice of Info	rmal Patent Application (PTO-152)	
2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948)	6. Interview Sur	nmary (PTO-413),	
Information Disclosure Statements (PTO-1449 or PTO/SB/	Paper No./M	ail Date mendment/Comment	
Paper No./Mail Date 4. Examiner's Comment Regarding Requirement for Deposit		tatement of Reasons for Allowance	
of Biological Material	9. ☐ Other	atoment of reasons for Allowance	
	5. 🗀 Other		

Allowable Subject Matter

- 1. Claims 10-16, 18 and 19 are allowed.
- 2. The following is an examiner's statement of reasons for allowance:
- 3. The prior arts of record do not anticipate or render obvious to one skilled in the art a method of repairing electrode pattern defects of a plasma display panel comprising performing an inspection process to determine a pit defect and a salient defect of the plasma display panel; performing a first one-step repairing process for filling the pit defect and performing a second repairing process for removing the salient defect.
- 4. The closest reference JP 2000-348623 (Fujiko) discloses a method of repairing electrode pattern defects of a plasma display defects comprising the steps of performing a one-step repairing process with a conductive paste for repairing the electrode pattern defects such as broken connection. However, Fujiko alone or in combination with any other references fail to teach or suggest the claimed step of performing an inspection process to determine salient defect and performing a second repairing process for removing the salient defect.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Tarifur R. Chowdhury whose telephone number is (571) 272-2287. The examiner can normally be reached on M-Th (6:30-5:00) Friday Off.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Robert Kim can be reached on (571) 272-2293. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

TRC January 31, 2006

TARIFUR R. CHOWDHURY